## (19) World Intellectual Property **Organization**

International Bureau





(43) International Publication Date 20 January 2005 (20.01.2005)

## (10) International Publication Number WO 2005/006398 A3

(51) International Patent Classification<sup>7</sup>: C23C 16/00, 16/455

(21) International Application Number:

PCT/US2004/018617

(22) International Filing Date: 10 June 2004 (10.06.2004)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:

60/482,861	27 June 2003 (27.06.2003)	US
60/506,864	30 September 2003 (30.09.2003)	US
60/509,563	9 October 2003 (09.10.2003)	US
10/759,857	17 January 2004 (17.01.2004)	US

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- (81) Designated States (unless otherwise indicated, for every kind of national protection available): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM,ZW.
- (84) Designated States (unless otherwise indicated, for every kind of regional protection available): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

#### **Declaration under Rule 4.17:**

as to the applicant's entitlement to claim the priority of the earlier application (Rule 4.17(iii)) for all designations

### **Published:**

- with international search report
- before the expiration of the time limit for amending the claims and to be republished in the event of receipt of amendments
- (88) Date of publication of the international search report: 1 September 2005

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: APPARATUS AND METHOD FOR CONTROLLED APPLICATION OF REACTIVE VAPORS TO PRODUCE THIN FILMS AND COATINGS

(57) Abstract: A vapor phase deposition method and apparatus for the application of thin layers and coatings on substrates. The method and apparatus are useful in the fabrication of electronic devices, micro-electromechanical systems (MEMS), Bio-MEMS devices, micro and nano imprinting lithography, and microfluidic devices. The apparatus used to carry out the method provides for the addition of a precise amount of each of the reactants to be consumed in a single reaction step of the coating formation process. The apparatus provides for precise addition of quantities of different combinations of reactants during a single step or when there are a number of different individual steps in the coating formation process. The precise addition of each of the reactants in vapor from is metered into predetermined set volume at a specified temperature to a specified pressure, to provide a highly accurate amount of reactant.



# INTERNATIONAL SEARCH REPORT

International application No.

PCT/US04/18617

A. CLASSIFICATION OF SUBJECT MATTER IPC(7) : C23C 16/00, 16/455				
US CL	: 118/715	a talia a troa		
	International Patent Classification (IPC) or to both nat	ional classification and IPC		
B. FIELI	OS SEARCHED			
Minimum documentation searched (classification system followed by classification symbols)  U.S.: 118/715				
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched				
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) Please See Continuation Sheet				
C. DOCT	JMENTS CONSIDERED TO BE RELEVANT			
Category *	Citation of document, with indication, where a	ppropriate, of the relevant passages	Relevant to claim No.	
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"P" document published prior to the international filing date but later than the priority date claimed		"&" document member of the same patent	family	
Date of the actual completion of the international search		Date of mailing of the international search report		
27 June 2005 (27.06.2005)		15 JUL 2003		
Name and mailing address of the ISA/US		Authorized officer		
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